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RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1771
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q64575

Tsuyoshi INOUE, et al.

Appln. No.: 09/874,314

Group Art Unit: 1771

Confirmation No.: 6107

Examiner: Daniel R. Zirker

Filed: June 06, 2001

For: SHEET FOR PROTECTING PAINT FILM

RESPONSE UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 1, 2004, please consider the remarks as submitted herewith on the accompanying pages.